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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: |) | |
| |) | |
| Hans Ott |) | Examiner: |
| |) | |
| Serial No.: 10/005,150 |) | Group Art Unit: 2622 |
| |) | |
| Filed: December 7, 2001 |) | Confirmation No. 8111 |

For: DEVICE FOR THE PIXEL-BY-PIXEL PHOTOELECTRIC
MEASUREMENT OF A PLANAR MEASURED OBJECT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97, the material listed on the attached form PTO-1449 is being brought to the attention of the Examiner for consideration in connection with the examination of the above-identified patent application. The references listed were cited in a Search Report for a corresponding European patent application.

To Applicant's knowledge and belief, the enclosed references are being submitted before a first action on the merits, pursuant to 37 C.F.R. §1.97(b)(3).

The filing of this Information Disclosure Statement shall not be construed to be a representation that a search has been conducted, nor shall it be construed as an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

Serial No. 10/005,150

Attorney Docket: 97634.00112

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

Respectfully submitted,

Date: October 18, 2004



Basam E. Nabulsi

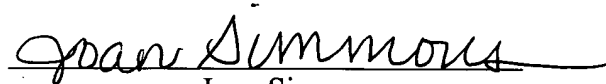
Reg. No. 31,645

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I hereby certify that the enclosed Information Disclosure Statement along with a PTO-1449 Form and the cited references are being deposited with the United States Postal Service as first class mail, postage prepaid, addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 18, 2004.

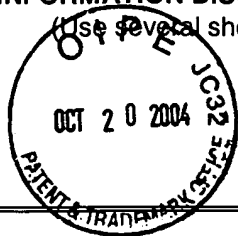
Dated: October 18, 2004



Joan Simmons

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| Form PTO-1449 (modified 2/91) | U.S. DEPT OF COMMERCE Patent and Trademark Office | Attorney Docket Number: 97634.00112 | Serial No.: 10/005,150 |
| INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) | | Applicants: | |
| | | Hans Ott | |
| | | Filing date: 12/7/01 | Group Art Unit: 2622 |



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| Examiner Initial | Patent number | Date | Inventor | Class | Sub class | Filing date if appropriate |
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| Examiner: | Date Considered: |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant. | |